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ney's Docket No.: 42P17279

**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:

Justin K. Brask et al.

Examiner:

Unassigned

Application No.:

10/642,546

Art Unit: Unassigned

Filed:

August 28, 2003

For: SELECTIVE ETCH PROCESS FOR MAKING A SEMICONDUCTOR DEVICE HAVING A HIGH-K GATE DIELECTRIC

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

## INFORMATION DISCLOSURE STATEMENT

Sir:

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**Teresa Mattox** 

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Pursuant to 37 C.F.R. § 1.97, this Information Disclosure Statement is being submitted under one of the following (as indicated by an "X" to the left of the appropriate paragraph):

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If there are any additional charges, please charge Deposit Account No. 02-2666.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Dated: 12/13/2004

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STATEMENT BY APPLICANT				First Named Inventor:	Justin K. Brask et al.	
(use as many sheets as necessary)			Art Unit	Unknown		
				Examiner Name	Unknown	
Sheet	1		of		Attorney Docket Number	42P17279
	U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.1	Num	Document Number ber-Kind Code <sup>2</sup> (If known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US-	5,368,687	11/29/1994	Sandhu et al.	
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Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document  Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T
		JP 05175174	7/13/1993	Nec Corp.		
		JP 2000216142	8/4/2000	Toshiba Corp.		
		WO 2004/021409	3/11/2004	Tokyo Electron Limited		
		WO 2004/030049	4/8/2004	Tokyo Electron Limited	<u> </u>	

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INFORMATION DISCLOSURE  STATEMENT BY APPLICATION  (use as many sheets as necessary)  Complete if Known  Application Number  Filing Date  First Named Inventor:  Justin K. Brask	03				
STATEMENT BY APPLICATION DISCLOSURE  Filing Date  First Named Inventor:  Justin K. Brask	)3				
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Art Unit Unknown					
Examiner Name Unknown	·				
Sheet 2 of 2 Attorney Docket Number 42P17279					
NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*  Cite No¹  Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volur number(s), publisher, city and/or country where published	e), title of the T <sup>2</sup> me-issue				
"Process for Selective Etching of Tantalum Oxide" IBM Technical Disclosure Bul Corp., New York, Vol. 27, No. 12 May 1985, page 7238, XP000807046	"Process for Selective Etching of Tantalum Oxide" IBM Technical Disclosure Bullentin, IBM Corp., New York, Vol. 27, No. 12 May 1985, page 7238, XP000807046				
Christenson K., et al. "Selective Wet Etching of High-K Gate Dielectrics" Diffusion Defect Data, Solid State Data, Part B, Solid State Phenomena, Vol. 92, 2003, part 132, XP008023569	Christenson K., et al. "Selective Wet Etching of High-K Gate Dielectrics" Diffusion and Defect Data, Solid State Data, Part B, Solid State Phenomena, Vol. 92, 2003, pages 129-132, XP008023569				
Bernet J., et al. "Wet Etch Enhancement of HfO2 Films by Implant Processing", I and Defect Data, Solid State Data, Part B, Solid State Phenomena, Vol. 92, 2003 11-14 XP008029227	Diffusion 3, pages				
European Search Report EP 04 01 7225					

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